

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Takako YAMAGUCHI et al.) : Examiner: S. A. Fraser
Application No.: 10/529,908) : Group Art Unit: 1795
35 U.S.C. § 371(c)) : Confirmation No.: 5277
Completion Date: December 16, 2005)
For: METHOD OF DETECTING RELATIVE : October 9, 2008
POSITION OF EXPOSRE MASK AND OBJECT)
TO BE EXPOSED, ALIGNMENT METHOD,
AND EXPOSURE METHOD USING THE)
SAME :
)

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT & SUBMISSION OF SUBSTITUTE SPECIFICATION

Sir:

In response to the Official Action dated July 9, 2008, please amend the above-identified application as follows: